



174H  
JFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Colin RAMSHAW et al.

**SERIAL NO:** 09/913,905

**GROUP ART UNIT:** 1741

**FILED:** 01/23/2002

**EXAMINER:** BHAT, NINA NMN

**FOR:** "ROTATING SURFACE OF REVOLUTION REACTOR WITH TEMPERATURE  
CONTROL MECHANISMS"

**ATTORNEY DOCKET NO.:** A01205US (98148.19)

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**RESPONSE**

*FEE PROCESSED*

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a response to the Office Action mailed on November 10, 2004. The Office Action set a three month deadline to respond making a response due February 10, 2005.

**AMENDMENT**

Please amend the application as follows:

03/14/2005 WHITCHEL 00000002 500694 09913905

01 FC:2201 300.00 DA